



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: Choi et al.

PATENT APPLICATION

Serial No: 10/616,799

Group Art Unit: Unassigned

Filed: July 10, 2003

Examiner: Unassigned

For: A method of manufacturing a vacuum chuck used in
imprint lithography

SUPPLEMENTAL PRELIMINARY AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

This amendment is filed in conjunction with
preliminary amendment filed July 10, 2003.

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